

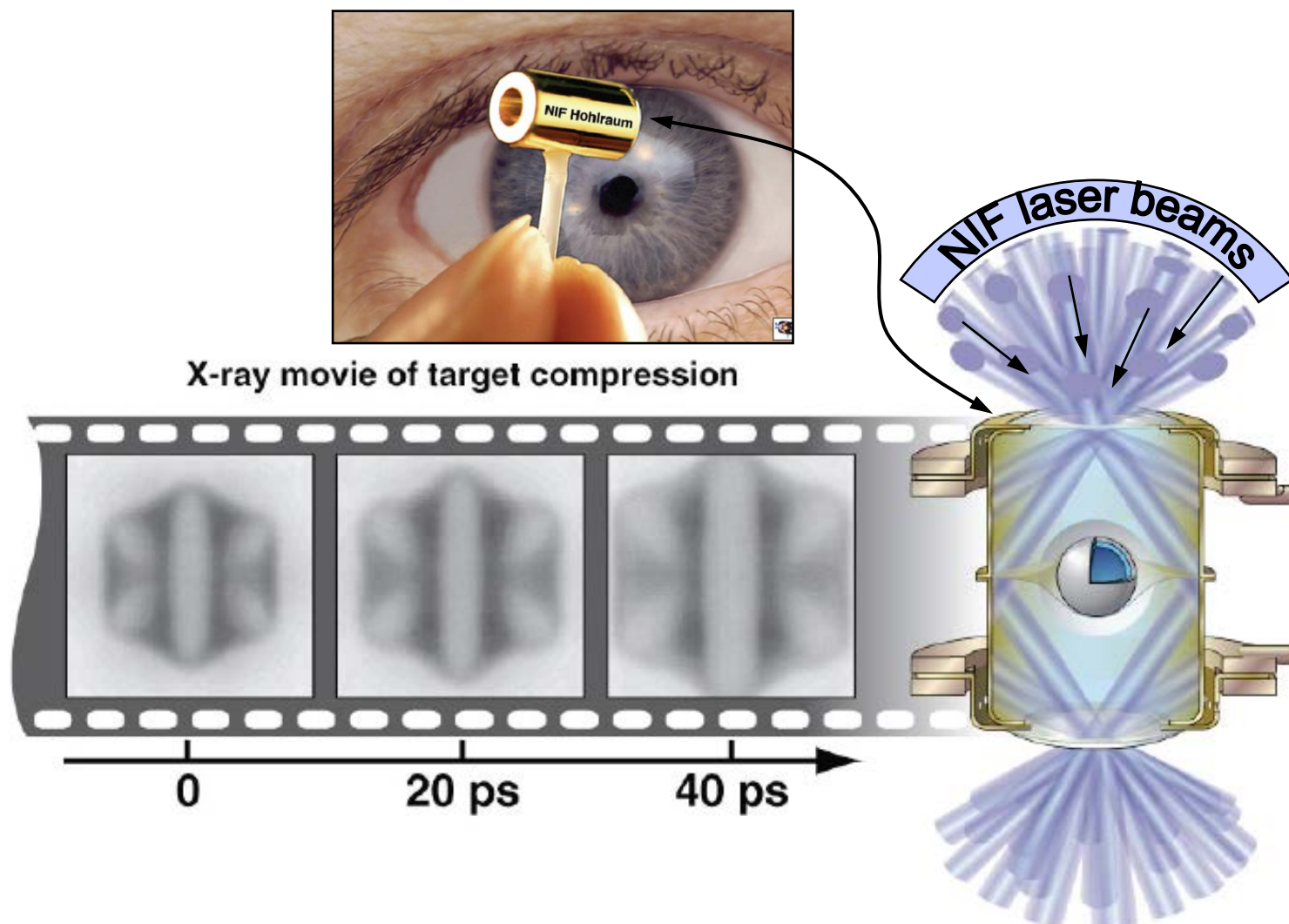


The Advanced Radiographic Capability, A Major Upgrade of the Computer Controls for the National Ignition Facility

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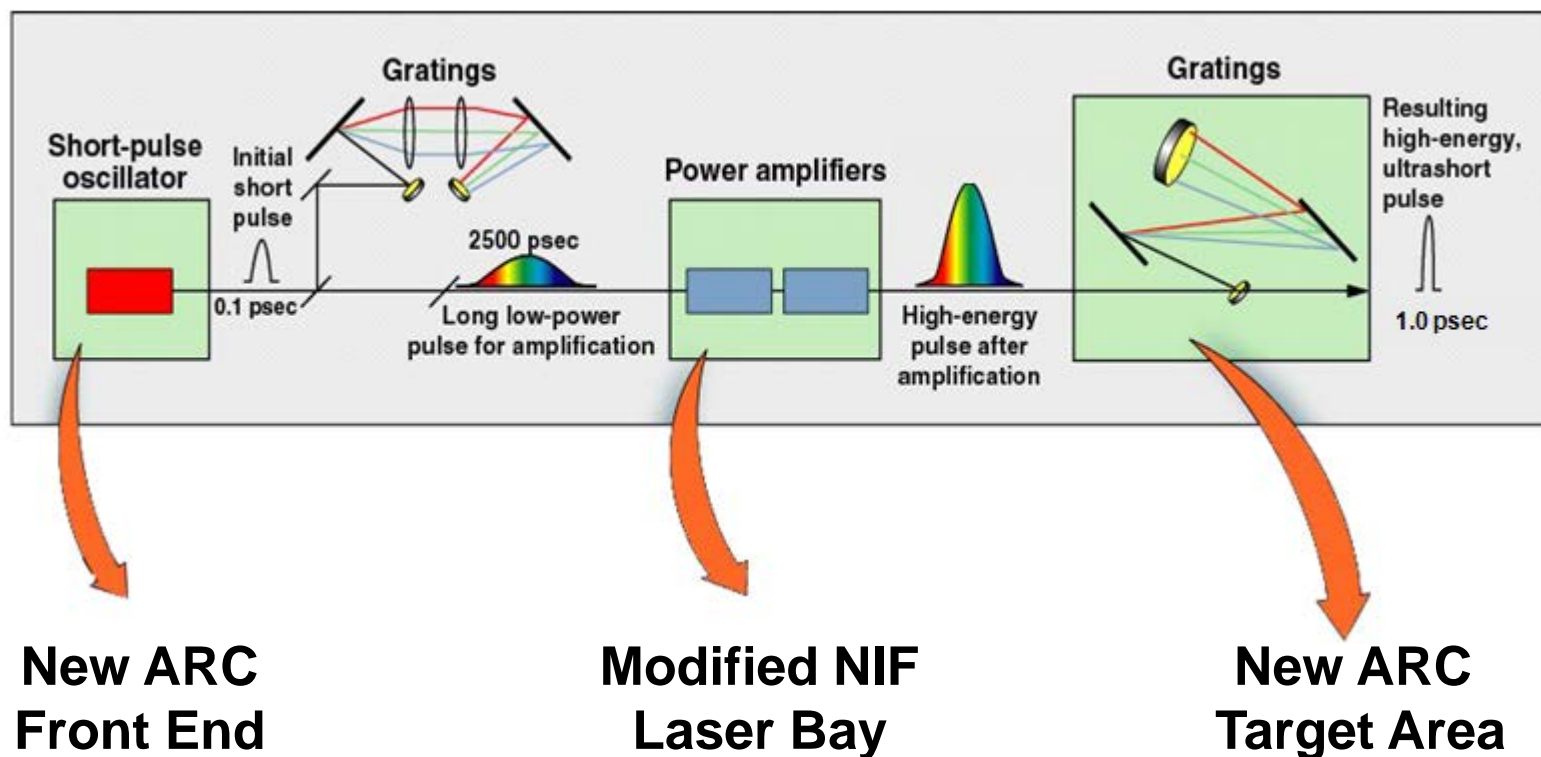
The ARC will provide a dynamic x-ray radiography of ICF implosions, a core requirement of NIF



Full scale ARC will provide NIF with 8 Petawatt-class pulses capable of generating multi-frame hard X-ray backlighting images

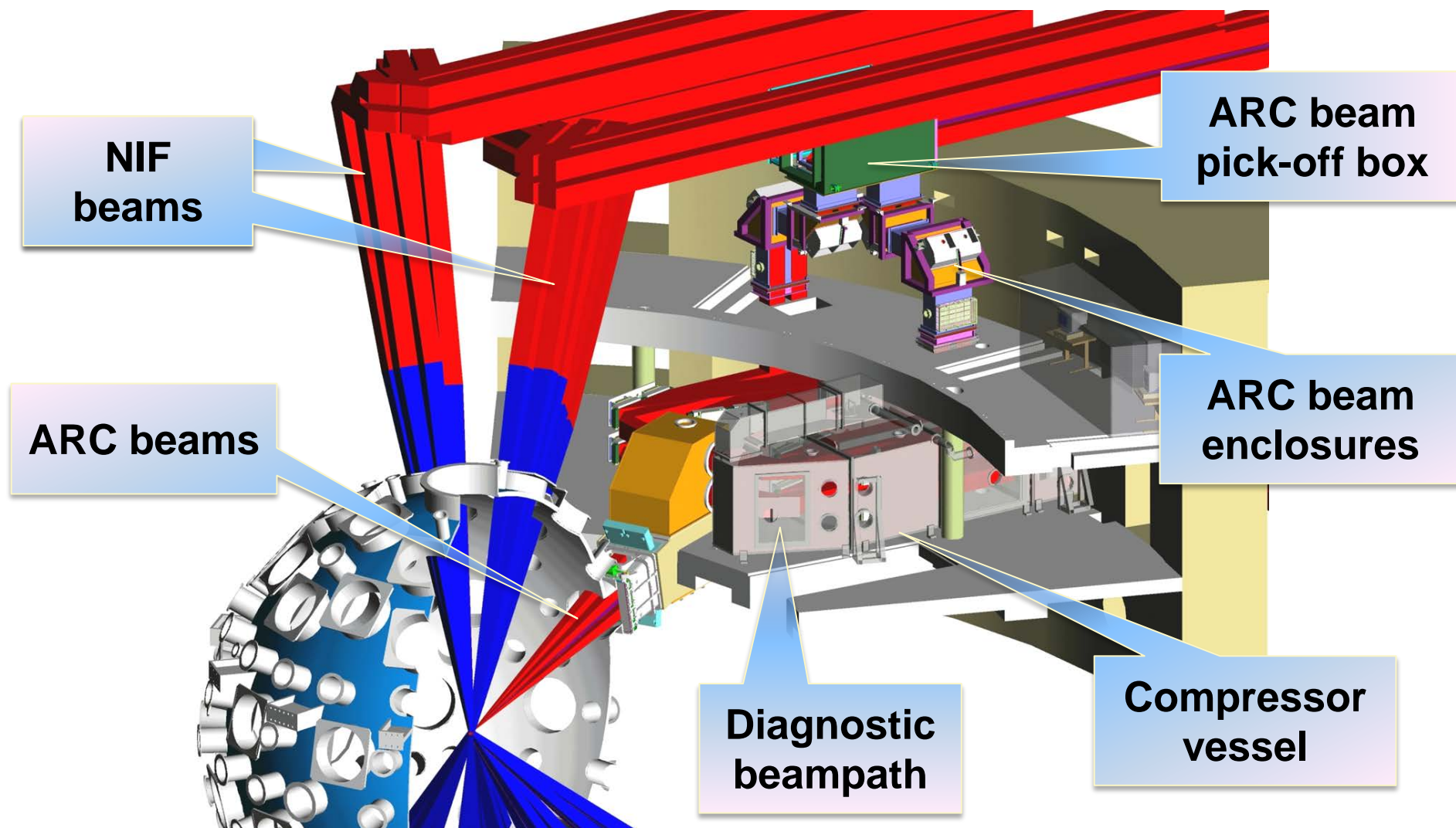
ARC chirped-pulse technology is used to produce short (1-50ps) laser pulses on NIF

- Generate a short laser pulse at low energy that has bandwidth
- Stretch the pulse in time and amplify using the existing NIF laser chain
- Recompress the pulse in the target area
- Focus onto targets with a parabolic mirror

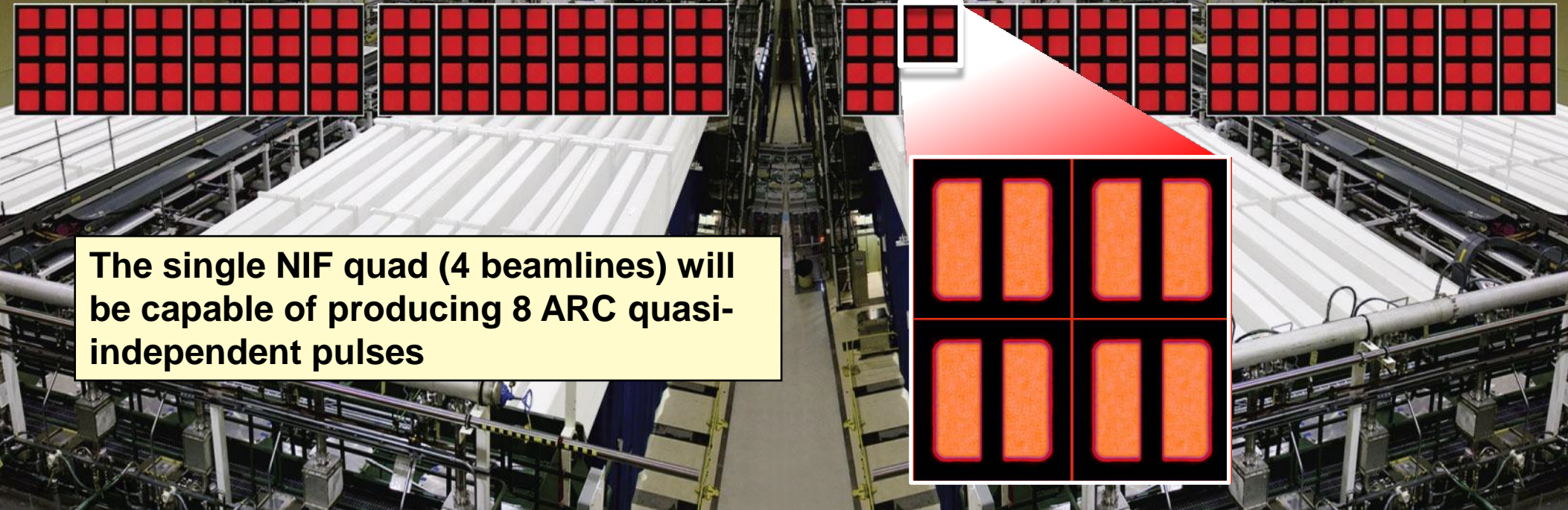


Stretching the pulse lowers the overall peak power allowing ARC to safely utilize NIFs main amplification chain

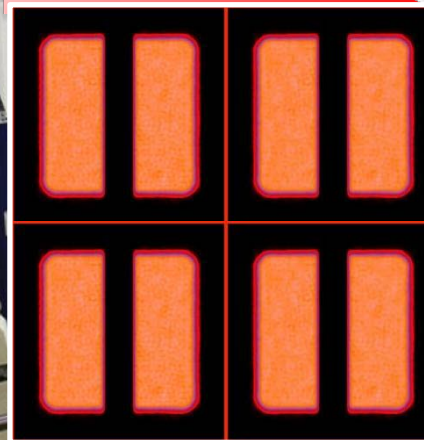
ARC will utilize up to a quad of NIF beams in the target bay for short-pulse use on target



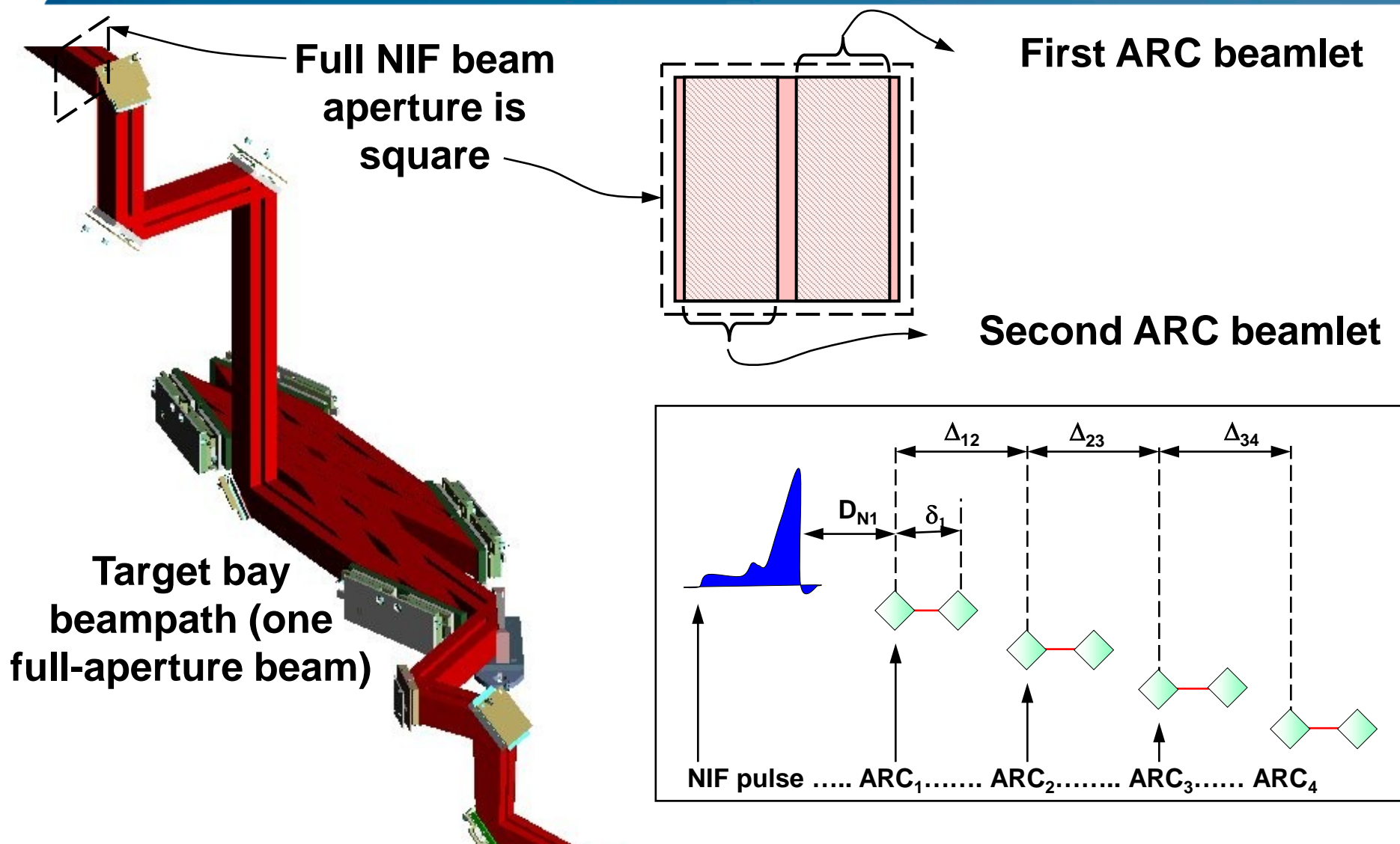
The modified quad will allow for either short pulse (ARC) or long pulse (NIF) operations



The single NIF quad (4 beamlines) will be capable of producing 8 ARC quasi-independent pulses

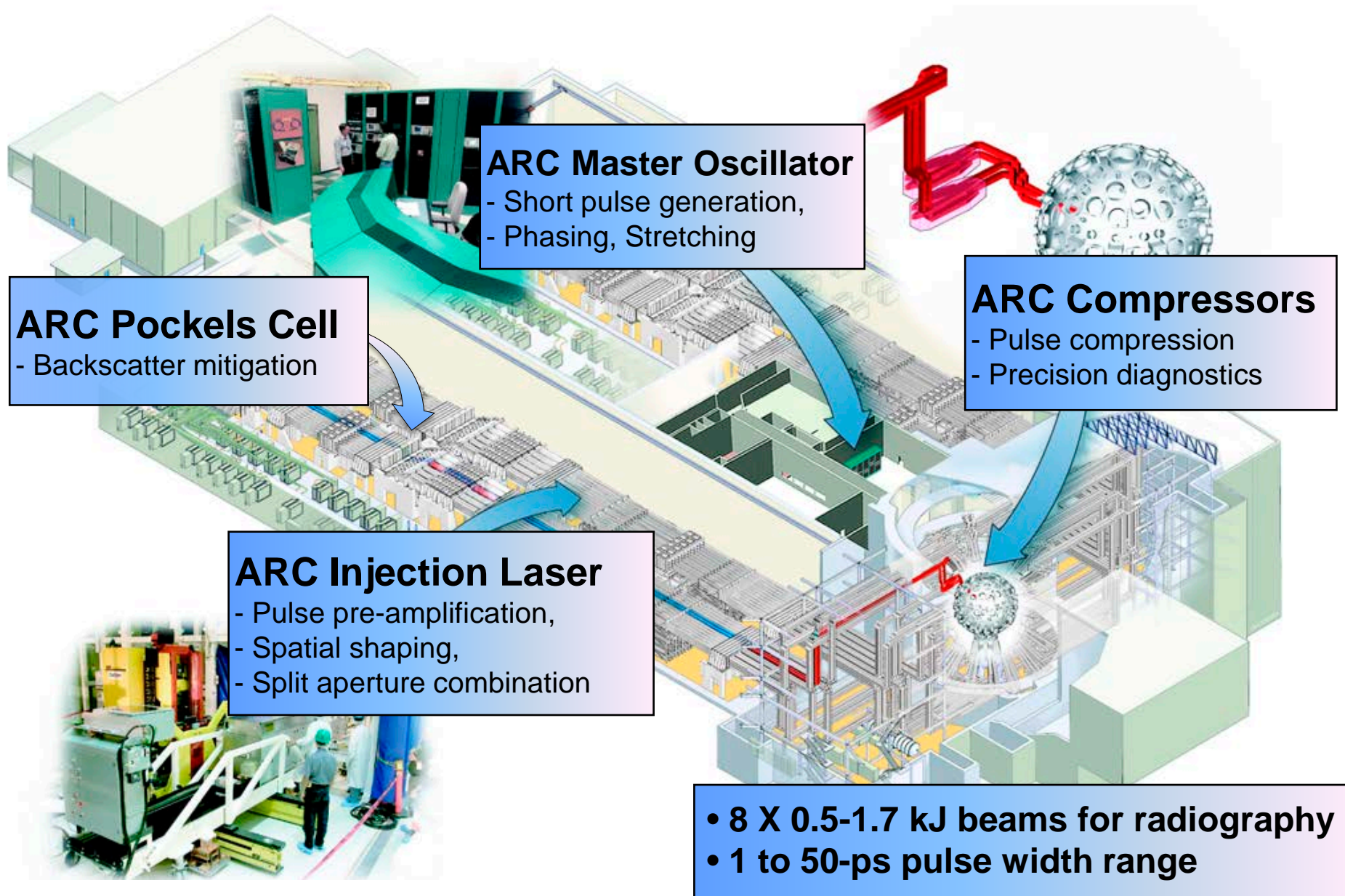


Each ARC beamline will be divided into two sub-apertures to double backlighting capabilities

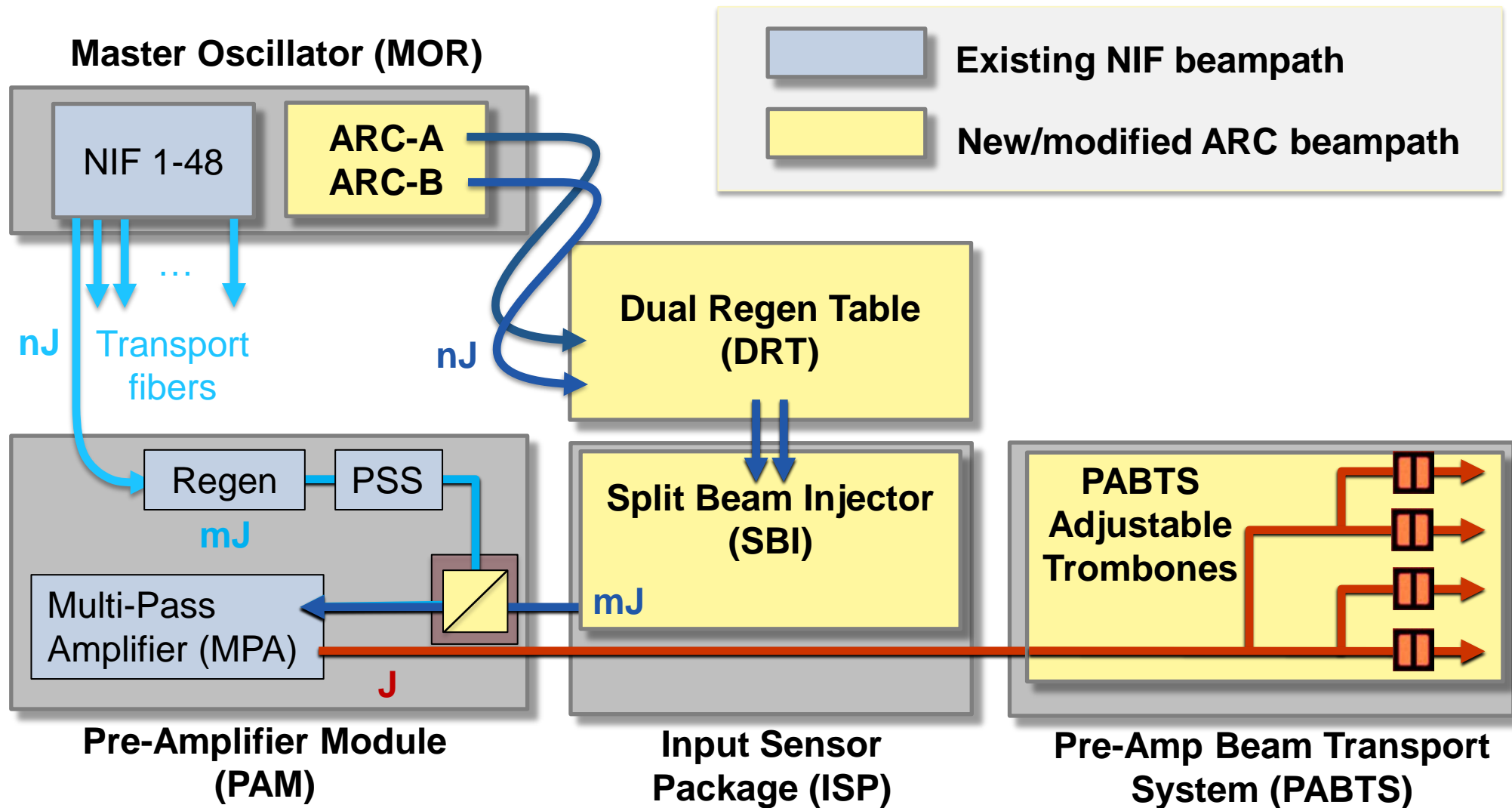


Each of the 8 beamlets can be independently focused and separated in time, to produce a pulsed-backlighter source

High-energy, short pulse generation requires four modifications to NIF's laser and controls architecture

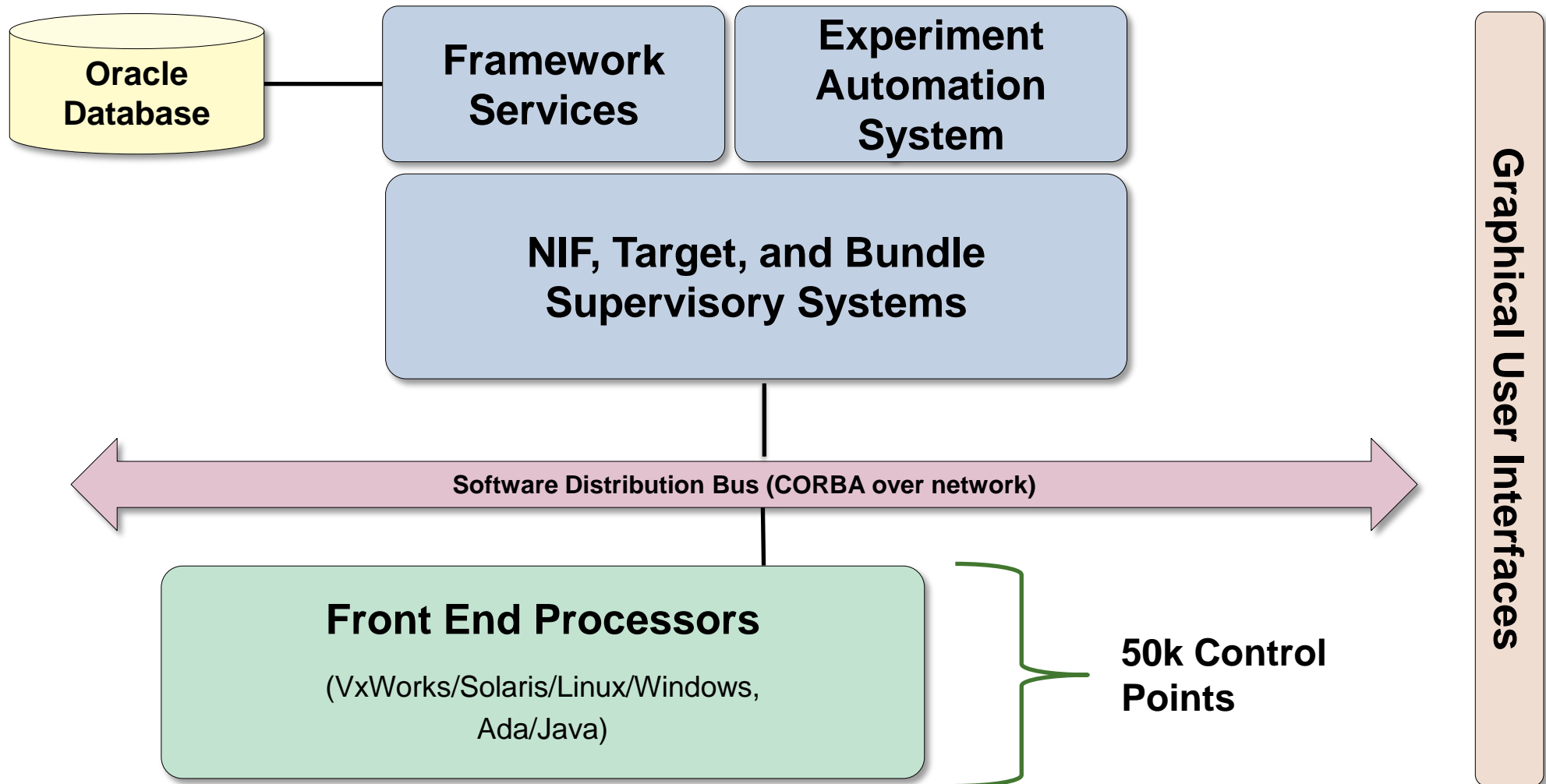


New ARC injection laser system provides independent control of short pulse characteristics



Propagation of either NIF or ARC pulse is controlled autonomously by shuttering either ARC or NIF dependent on experimental goals

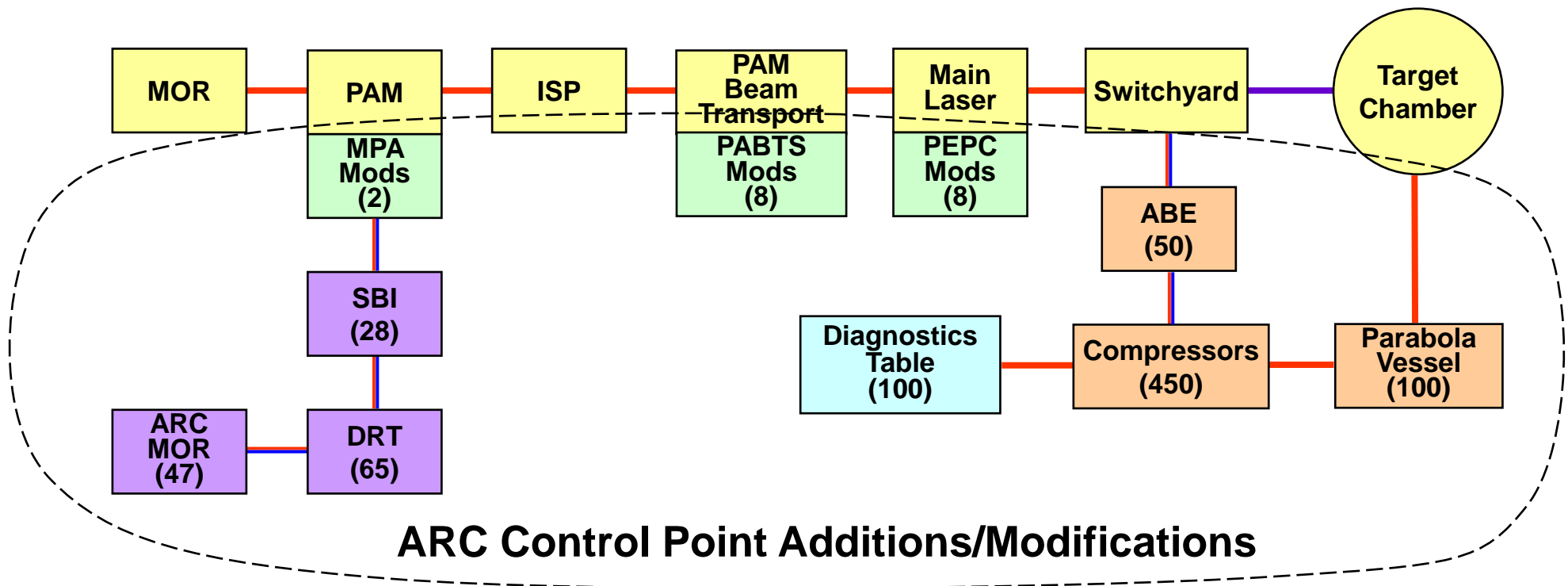
The segmented and layered software architecture allows rapid integration of ARC to existing controls



Minimizing impact to existing NIF controls significantly reduces the integration qualification duration

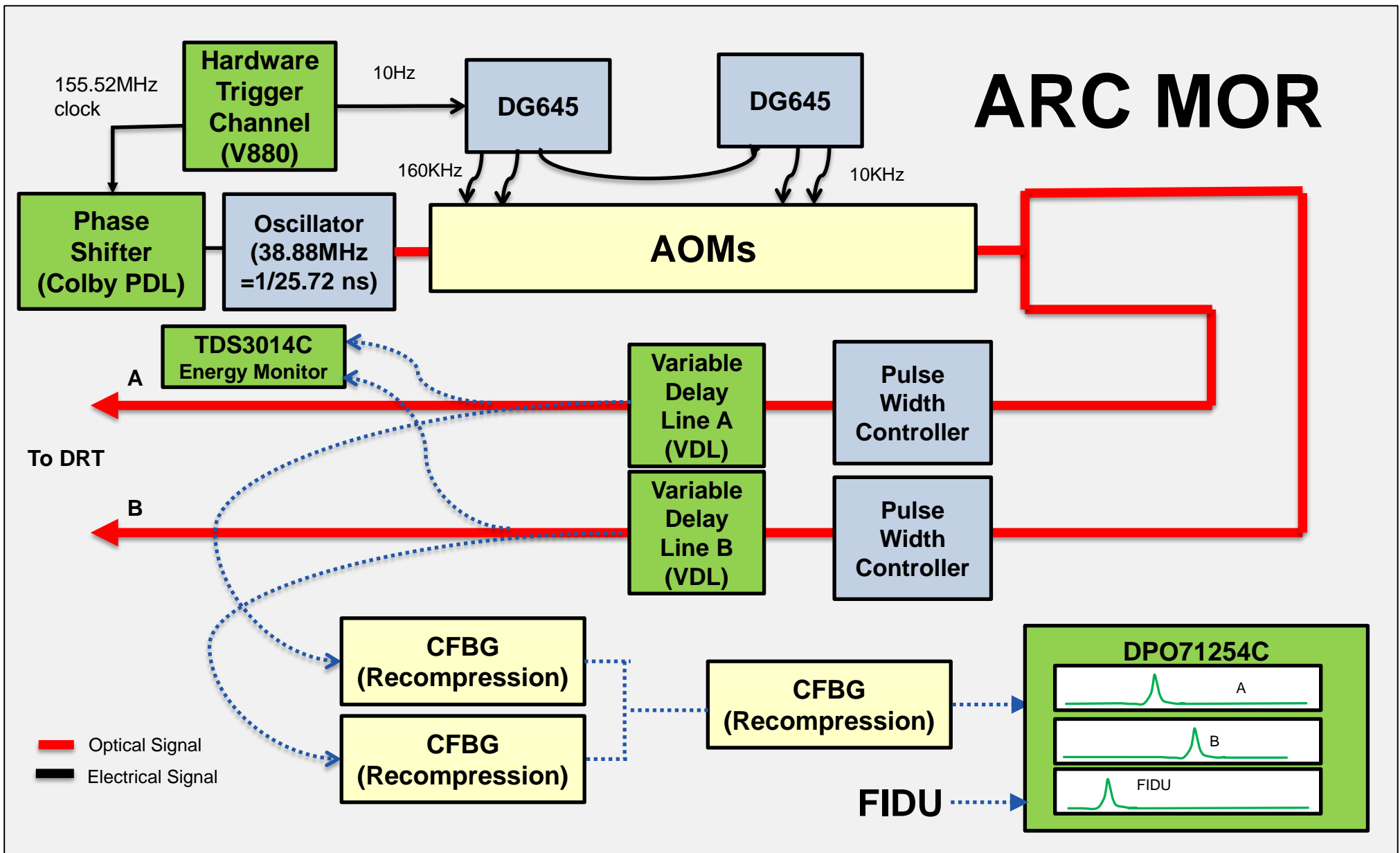
ICCS ARC controls integration is a large scale development but is well underway

- ARC will add 70% additional control points (850) to existing NIF quad
- Heavily leveraging existing controls (80% reuse of NIF controls SW)
- 13 new or modified control types required for ARC
- >60% controls already deployed and undergoing commissioning



ICCS's flexible, object oriented architecture is designed to rapidly integrate ARC's new control points into automated shot framework

Time synchronization of ARC to NIF pulses required a complex series of feedback controls loops

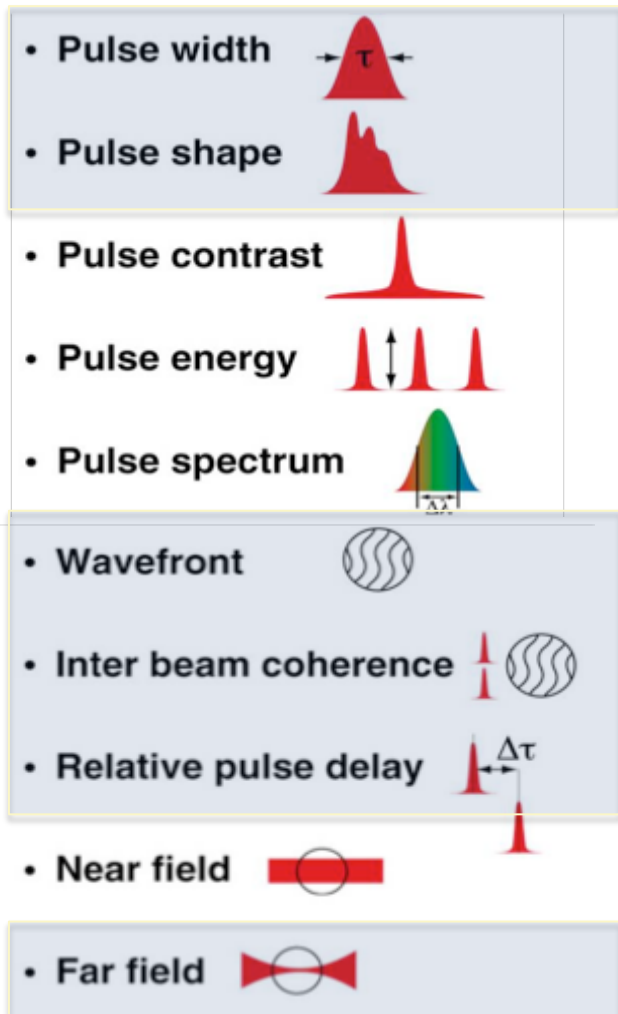


Significant new software development is focused in the complex short-pulse laser diagnostic suite



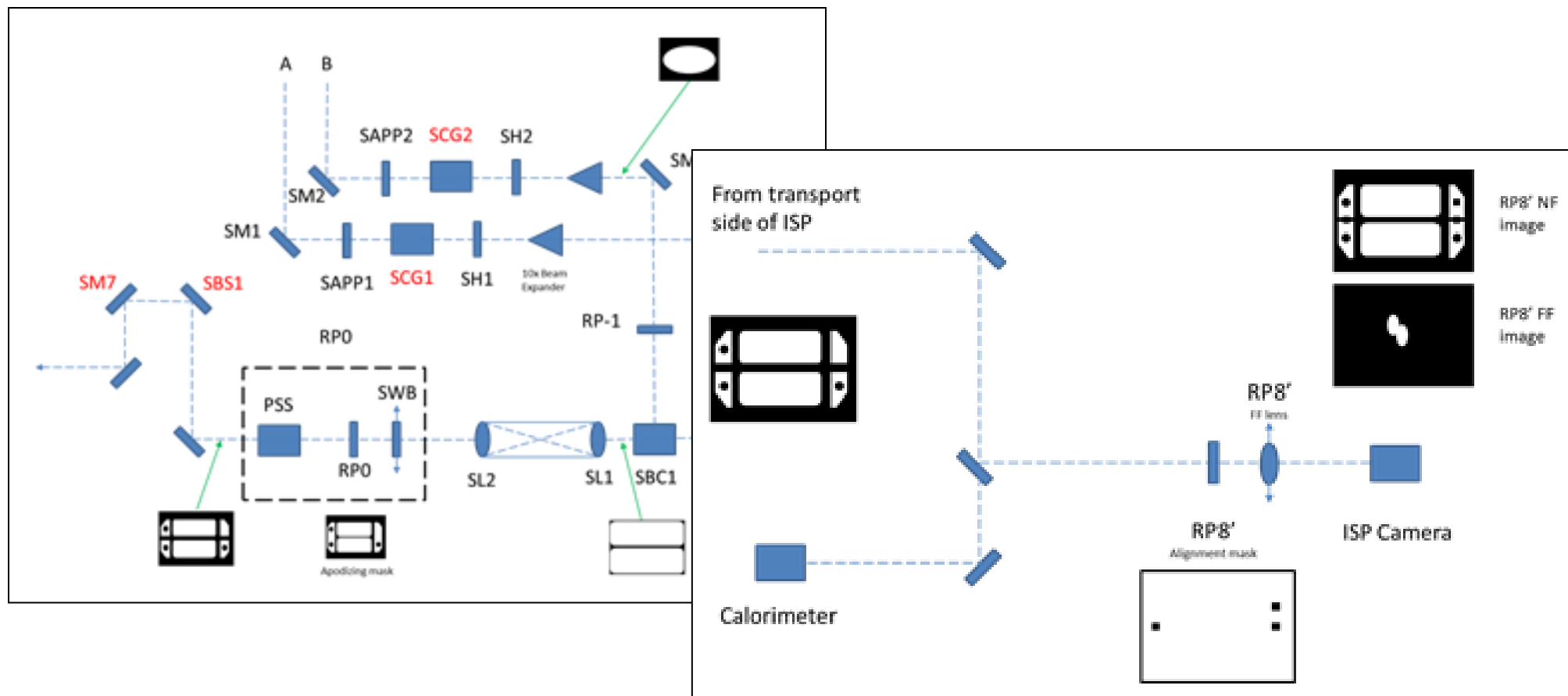
New controls development

Several new software controls being developed for diagnostics to allow verification of ARC experiments in NIF automated shot cycle



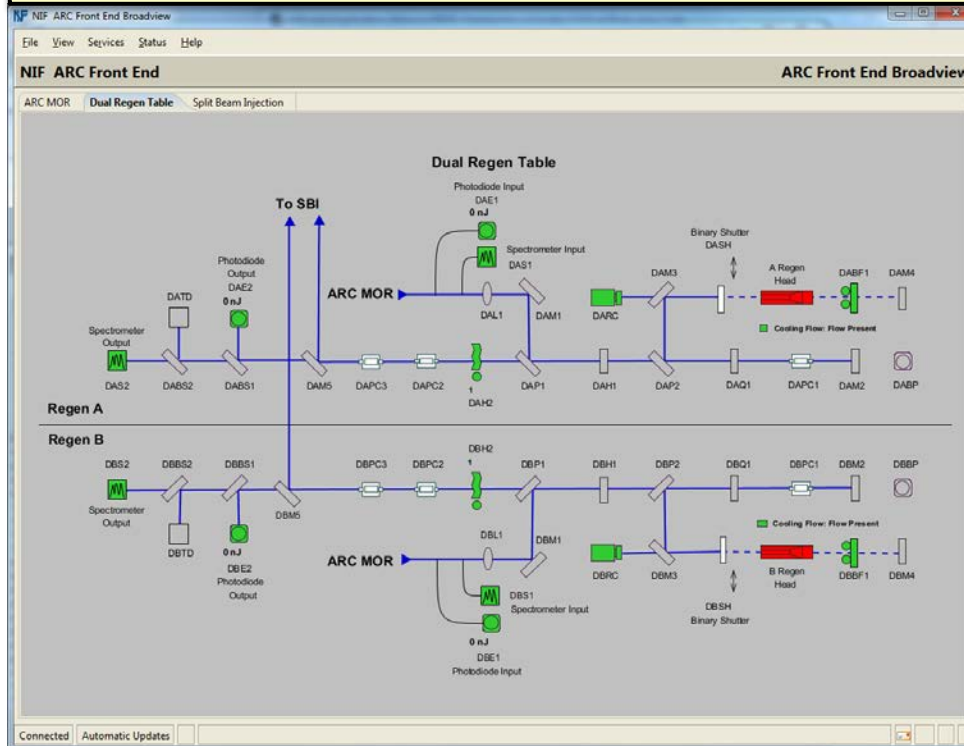
Beam alignment of the ARC laser is automated from origin to target

- A series of automated alignment loops align the entire ARC beampath
- Each feedback control loop uses image analysis measurements to adjust a series of mirrors to align the ARC beams with very high accuracy
- A total of 20 new control loops are required to align the entire ARC beampath

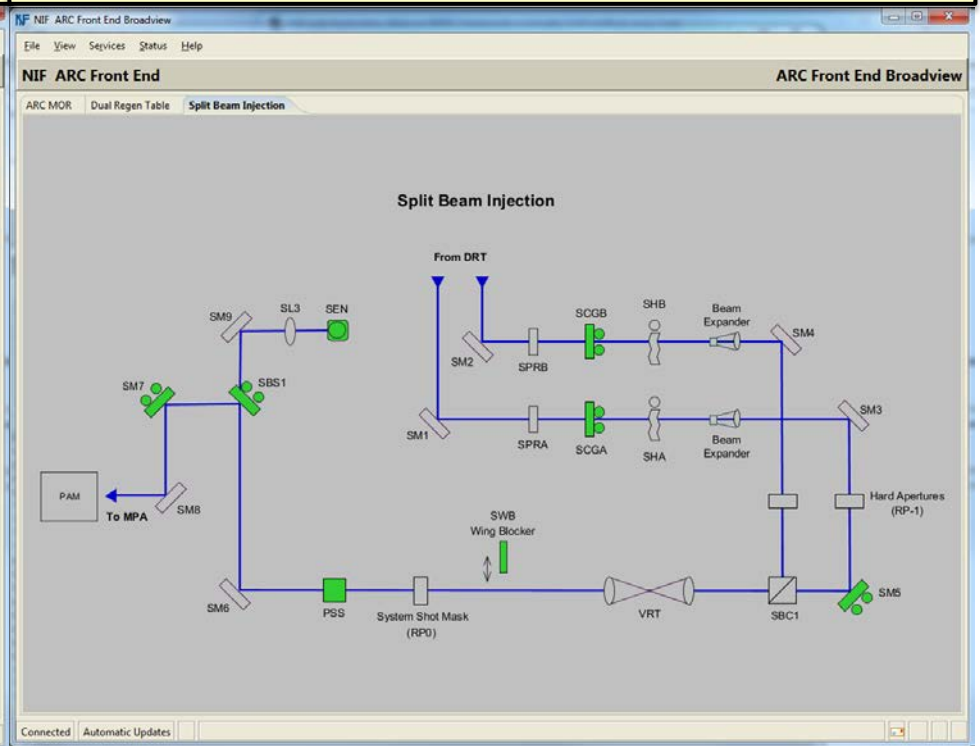


ARC graphical interfaces developed to provide operations with continuous feedback of device state

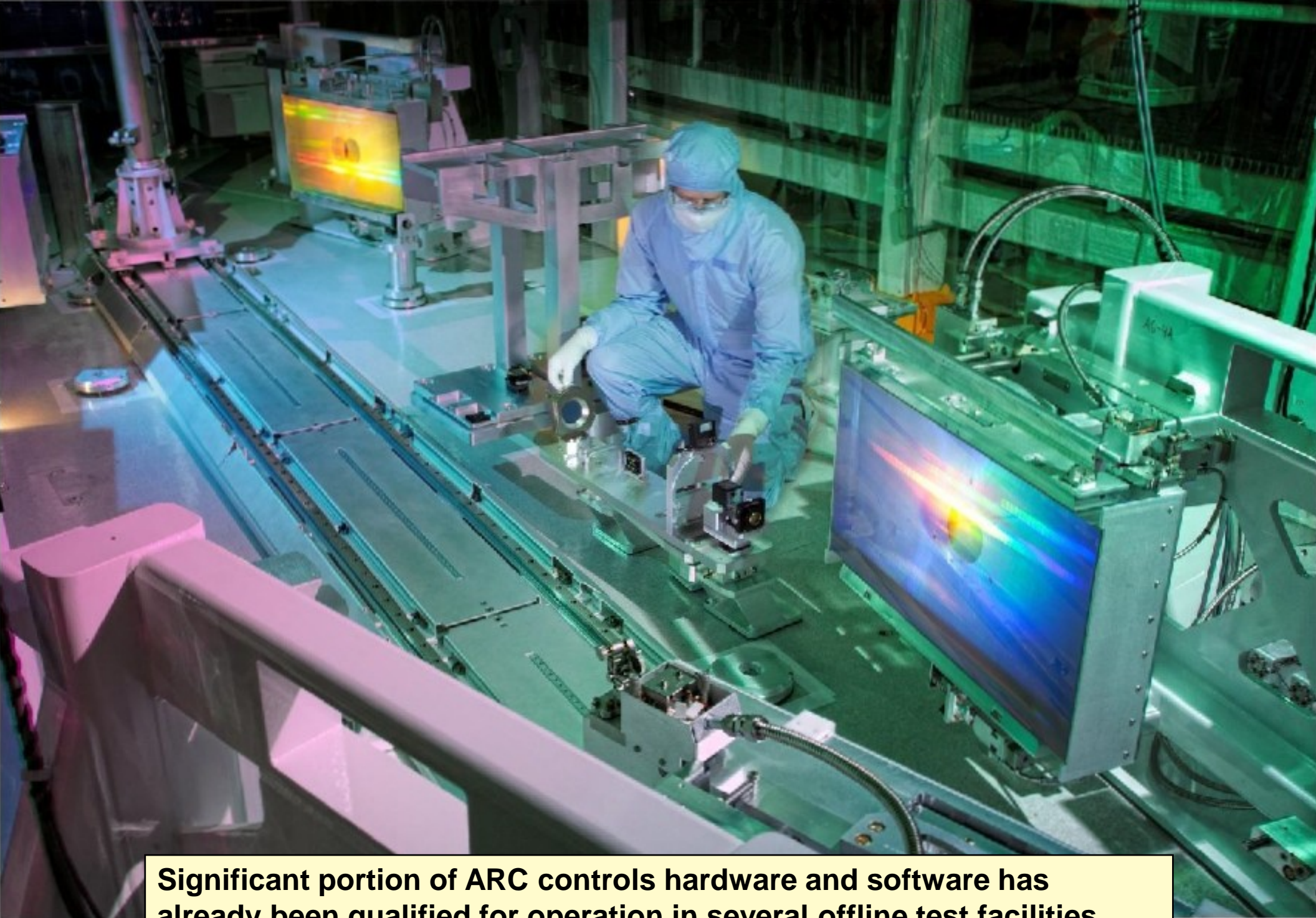
DRT Broadview



SBI Broadview

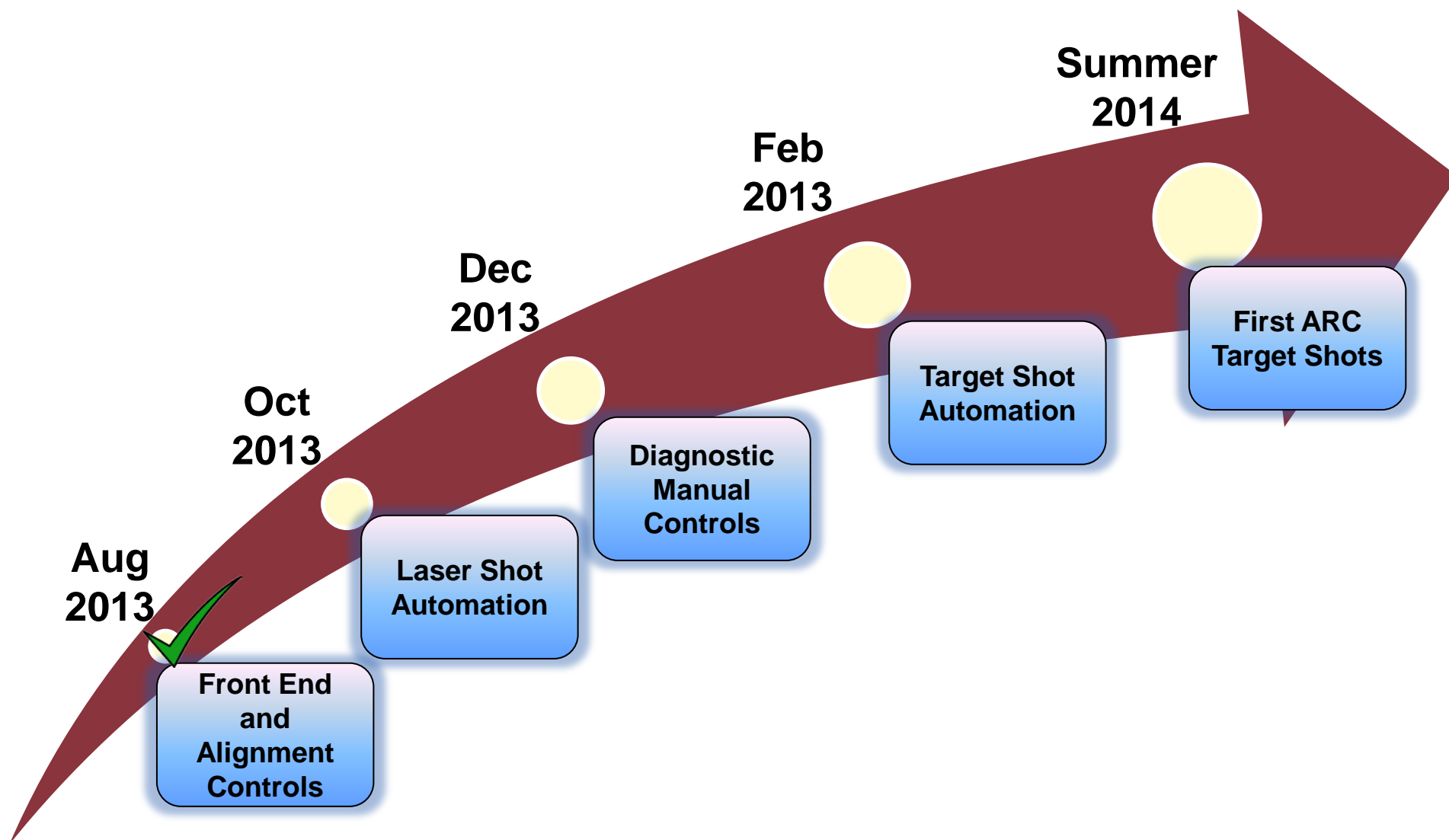


Schematic interfaces provide operation staff with a high level system overview and provide a realistic reference for maintenance activities



Significant portion of ARC controls hardware and software has already been qualified for operation in several offline test facilities

Significant progress to ARC controls qualification has already been accomplished



Phased deployment of ARC capabilities reduces overall project deployment and commissioning risks

NIF

